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	Filing Date		2004-01-20
	First Named Inventor	Ronald J. Berenson	
	Art Unit	1651	
	Examiner Name	Taeyoon Kim	
	Attorney Docket Number	980034.417C5	

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/TK/	1	JACKSON et al., Small-Scale Monoclonal Antibody Production In Vitro: Methods And Resources, Proceedings of the Production of Monoclonal Antibodies Workshop, August 29, 1999, Bologna, Italy, <a href="http://altweb.jhsph.edu/topics/mabs/ardf/jackson.htm">http://altweb.jhsph.edu/topics/mabs/ardf/jackson.htm</a> , accessed April 17, 2007.	<input type="checkbox"/>
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